

2812

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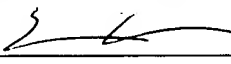
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TRANSMITTAL FORM <i>(to be used for all correspondence after initial filing)</i>		Application Number	09/987,004
		Filing Date	November 13, 2001
		First Named Inventor	Shone TOMOFUMI
		Group Art Unit	2812
		Examiner Name	Unassigned
Total Number of Pages in This Submission		Attorney Docket Number	0819-0687

ENCLOSURES (check all that apply)

<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input type="checkbox"/> Amendment / Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Declaration and Power of Attorney <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, Number of CD(s) _____	<input type="checkbox"/> After Allowance Communication to Group <input checked="" type="checkbox"/> Preliminary Amendment
Remarks <input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge any additional fees required or credit any overpayments to Deposit Account No. 19-2380 for the above identified docket number.		RECEIVED MAR 19 2002 TC 2800 MAIL ROOM

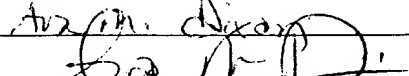
SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm or Individual name	Eric J. Robinson, Reg. No. 38,285 Nixon Peabody LLP 8180 Greensboro Drive Suite 800 McLean, VA 22102
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MAR 19 2002
TC 2800 MAIL ROOM

In re Patent Application of

) Art Unit: 2812

Shone TOMOFUMI

) Examiner: Unassigned

Serial No. 09/987,004

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Filed: November 13, 2001

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For: METHOD OF FABRICATING
ORGANIC THIN FILM

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PRELIMINARY AMENDMENT

Honorable Commissioner of Patents

Washington, D.C. 20231

Sir:

Please preliminarily amend the above identified patent application as follows:

IN THE SPECIFICATION:

Please amend the specification as follows:

On Page 4, Second Full Paragraph, continuing through Page 6, First Partial Paragraph

A second method for fabricating an organic thin film according to the present invention comprises the steps of:

forming an undercoating film made of silicon nitride or silicon nitride oxide on a substrate; wet-cleaning the undercoating film using a cleaning liquid; and forming an organic thin film with a thickness of about 100nm or thinner on the undercoating film, of which wet-cleaning has been completed, by turning the substrate and providing a liquid organic material onto the substrate; wherein the organic material contains at least one solvent selected from the group consisting of propylene glycol monomethyl ether acetate, propylene glycol monomethyl ether, ethyl lactate, ethyl methoxy propionate, ethyl ethoxy propionate, 2-heptanone, ethyl pyruvate, diethylene glycol monomethyl ether, methyl cellosolve acetate, propylene glycol monoethyl ether acetate, ethyl methoxy propionate, methyl lactate and methyl pyruvate.